



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Sumio OGAWA et al.
Title: METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICES
Appl. No.: 10/044,964
Filing Date: 01/15/2002
Examiner: Shella S. Rao
Art Unit: 2125

CERTIFICATE OF MAILING

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

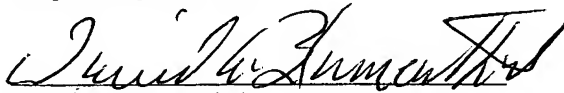
Commissioner:

I hereby certify that the following paper(s) and/or fee along with any attachments referred to or identified as being attached or enclosed are being deposited with the United States Postal Service as First Class Mail under 37 C.F.R. § 1.8(a) on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450.

1. Amendment and Reply Under 37 C.F.R. § 1.111
2. Amendment Transmittal
3. Postcard

April 25, 2005
Date

Respectfully submitted,


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Atty. Dkt. No. 088941-0203

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AMENDMENT AND REPLY UNDER 37 CFR 1.111

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Sir:

This communication is responsive to the Non-Final Office Action dated February 9, 2005, concerning the above-referenced patent application.

Please amend the application as follows:

04/28/2005 RMEBRANT 00000039 190741 10044964

01 FC:1201 200.00 DA